

INVENTOR INFORMATION

Inventor One Given Name:: Shunpei
Family Name:: YAMAZAKI
Postal Address Line One:: c/oSemiconductor Energy Laboratory Co.,Ltd
Postal Address Line Two:: 398, Hase,
City:: Atsugi-shi
State or Province:: Kanagawa-ken
Country:: Japan
Postal or Zip Code:: 243-0036
Citizenship Country:: Japan
Inventor Two Given Name:: Hisashi
Family Name:: OHTANI
Postal Address Line One:: c/oSemiconductor Energy Laboratory Co.,Ltd
Postal Address Line Two:: 398, Hase,
City:: Atsugi-shi
State or Province:: Kanagawa-ken
Country:: Japan
Postal or Zip Code:: 243-0036
Citizenship Country:: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22204
Fax One:: (703) 883-0370
Electronic Mail One:: pluther@nixonpeabody.com

APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING A SEMICONDUCTOR
Title Line Two:: DEVICE
Total Drawing Sheets:: 17
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 740756-2406
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204
Registration Number One:: 38285
Registration Number Two:: 35483
Registration Number Three:: 45285
Registration Number Four:: 26477
Registration Number Five:: 28290

CONTINUITY INFORMATION

This application is a:: DIVISION OF

Foreign Application One:: 09-308043
Filing Date:: 10-21-1997
Country:: Japan
Priority Claimed:: Yes
Foreign Application Two:: 10-152305
Filing Date:: 05-16-1998
Country:: Japan
Priority Claimed:: Yes

Source:: PrintEFS Version 1.0.1

[illegible]